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#2

**INFORMATION CITED BY APPLICANT(S) THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION**

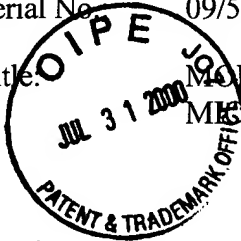
Applicants: Schwalbe et al.

Attorney Docket No. CELL0013

Serial No. 09/578,224

Filed: May 24, 2000

Title: MODULAR CHEMICAL PRODUCTION SYSTEM INCORPORATING A
MICROREACTOR



U.S. PATENT DOCUMENTS

*Examiner Initial	ID	Document No.	Date	Name	Class	Sub- Class
JAL	US1	3,881,701	5/6/1975	Schoenman et al.	259	4
JAL	US2	4,222,671	9/16/1980	Gilmore	366	337
JAL	US3	4,728,502	3/1/1988	Hamill	422	116
JAL	US4	5,209,906	5/11/1993	Watkins et al.	422	200
JAL	US5	5,534,328	7/9/1996	Ashmead et al.	428	166
JAL	US6	5,580,523	12/3/1996	Bard	422	50
JAL	US7	5,595,712	1/21/1997	Harbster et al.	422	129
JAL	US8	5,690,763	11/25/1997	Ashmead et al.	156	60
JAL	US9	5,741,466	4/21/1998	Bodnaras	422	228
JAL	US10	5,811,062	9/22/1998	Wegeng et al.	422	129
JAL	US11	5,961,932	10/5/1999	Ghosh et al.	422	193
JAL	US12	5,976,472	11/2/1999	Chatterjee et al.	422	130
JAL	US13	5,580,523	12/3/1996	Bard	422	50

FOREIGN PATENT DOCUMENTS

NONE CITED

OTHER INFORMATION

NONE CITED

Jennifer A. Leung

Examiner's Signature

April 8, 2003

Date

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RMA:mlb
7/20/00



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT LISTING SHEET

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#4

Information Cited By Applicant(s) That May Be Material To
The Prosecution Of The Subject Application

Applicants: Schwalbe et al. Attorney Docket No. CELL0013
Serial No.: 09/578,224 Group Art Unit: 1764
Filed: May 24, 2000 Examiner:
Title: MODULAR CHEMICAL PRODUCTION SYSTEM INCORPORATING A
MICROREACTOR

U.S. PATENT DOCUMENTS

NONE CITED

FOREIGN PATENT DOCUMENTS

<u>*Examiner Initial</u>	<u>ID</u>	<u>Document No.</u>	<u>Publication Date</u>	<u>Country</u>	<u>Class</u>	<u>Sub- Class</u>	<u>Translation ?</u>
JAL	F1	WO 98/38487	03 Sept 1998	US	6	GOIN 1/31	

OTHER INFORMATION

<u>*Examiner Initial</u>	<u>Document No.</u>	<u>Document Information</u>
JAL	O1	van den Berg, A. et al. 1996. "Modular Concept for Miniature Chemical Systems." <i>DECHEMA Monographs</i> : 132: pp 109-23.

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OCT 30 2002

TC 1700

Jennifer A. Leung

Examiner's Signature

April 8, 2003

Date

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RMA:MCK:ssa
10/23/02

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SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT LISTING
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Information Cited By Applicant(s) That May Be Material To
The Prosecution Of The Subject Application

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Applicants: Schwalbe et al. Attorney Docket No. CELL0013
Serial No.: 09/578,224 Group Art Unit: 1764
Filed: May 24, 2000 Examiner:
Title: MODULAR CHEMICAL PRODUCTION SYSTEM INCORPORATING A
MICROREACTOR

U.S. PATENT DOCUMENTS

NONE CITED

FOREIGN PATENT DOCUMENTS

*Examiner Initial	ID	Document No.	Publication Date	Country	Class	Sub- Class	Translation ?
JAL	F1	WO 00/62919	26/10/2000	Germany	B01J19/00	A1	Yes
	F2	WO 98/38487	03/09/1998	US	G01N1/31	A2	Yes

Duplicate Reference, JAL

OTHER INFORMATION

*Examiner Initial	Document No.	Document Information
	01	van den Berg, A. et al. 1996. "Modular Concept for Miniature Chemical Systems." <i>DECHEMA Monographs</i> 132:109-23.

Duplicate Reference, JAL

Jennifer A. Leung
Examiner's Signature

April 8, 2003
Date

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RMA:MCK:ssa
11/15/02



THIRD SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT LISTING
SHEET

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Information Cited By Applicant(s) That May Be Material To
The Prosecution Of The Subject Application

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Applicants: Schwalbe et al. Attorney Docket No. CELL0013
Serial No.: 09/578,224 Group Art Unit: 1764
Filed: May 24, 2000 Examiner:
Title: MODULAR CHEMICAL PRODUCTION SYSTEM INCORPORATING A
MICROREACTOR

U.S. PATENT DOCUMENTS

NONE CITED

FOREIGN PATENT DOCUMENTS

<u>*Examiner</u> <u>Initial</u>	<u>ID</u>	<u>Document No.</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Class</u>	<u>Sub-</u> <u>Class</u>	<u>Translation?</u>
<i>JAL</i>	F1	WO 01/68257	20.09.2001	US	BO1L	3/00	

OTHER INFORMATION

NONE CITED

Jennifer A. Leung

Examiner's Signature

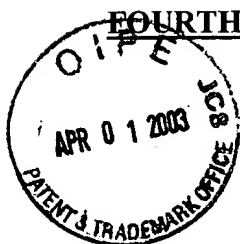
April 8, 2003

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*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RMA:MCK:ssa
12/4/02

FOURTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT LISTING
SHEET



Information Cited By Applicant(s) That May Be Material To
The Prosecution Of The Subject Application

Applicants: Schwalbe et al Attorney Docket No. CELL0013
 Serial No.: 09/578,224 Group Art Unit: 1764
 Filed: May 24, 2000 Examiner:
 Title: MODULAR CHEMICAL PRODUCTION SYSTEM INCORPORATING A
 MICROREACTOR

U.S. PATENT DOCUMENTS

*Examiner Initial	ID	Document No.	Date	Name	Class	Sub- Class
JAL	US1	5,641,400	06/24/1997	Kaltenbach et al.	210	198
JAL	US2	5,928,880	07/27/1999	Wilding et al.	435	7.21
JAL	US3	6,171,865	01/09/2001	Weigl et al	436	52
JAL	US4	6,192,596	02/27/2001	Bennett et al.	34	76

FOREIGN PATENT DOCUMENTS

NONE CITED

OTHER INFORMATION

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TC 1700

Jennifer A. Leung
 Examiner's Signature

April 14, 2003
 Date

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RMA:MCK:ssa
 3/27/03